INFORMATION DISCLOSURE **CITATION FORM FOR**

Docket No.: 041A.0002.U1(US)

Serial No.: 10/674,842

PATENT APPLICATION (FORM PTO-1449)		Applicant(s): A	Applicant(s): Ackerman et al.						
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	(Substitute)	Filing Date: Sep		2					
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Page No.: 1 of: 1

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PATENT APPLICATION		Applicant(s): A	Applicant(s): Ackerman et al.						
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Examiner's Signature: /Frederick Parker/ Date Considered: 05/25/2006

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